

Title (en)

WASTES TREATING METHOD AND DEVICE

Title (de)

MÜLLBEHANDLUNGSVERFAHREN UND VORRICHTUNG

Title (fr)

PROCEDE ET DISPOSITIF DE TRAITEMENT DE DECHETS

Publication

**EP 1284389 A4 20050316 (EN)**

Application

**EP 00929845 A 20000524**

Priority

JP 0003306 W 20000524

Abstract (en)

[origin: EP1284389A1] The present invention provides a method for waste treatment, in which wastes are incompletely burned or partially oxidized in a partial oxidation furnace in which combustion reaction takes place to yield combustible gas having a concentration converted to Oxygen of -30 to 1% at the outlet of the partial oxidation furnace; the combustible gas is introduced into a dust separator at a temperature of 250 to 800 DEG C to reduce the dust concentration to 0.1 g/Nm<sup>3</sup> or lower; and after hydrogen chloride is removed from the combustible gas, from which dust is removed, by a wet gas treatment apparatus as necessary so that the concentration thereof is reduced to 20 ppm, the combustion gas is burned in a combustion furnace at a high temperature. With this method, wastes can be partially oxidized so that the concentration of dust that causes the corrosion of boiler tube etc. does not increase, and heat can be recovered from exhaust gas with high efficiency. <IMAGE>

IPC 1-7

**F23G 5/027; F23G 5/16; F23G 5/30; F23G 5/46; F23J 15/02; F23J 15/04**

IPC 8 full level

**F23G 5/027 (2006.01); F23G 5/16 (2006.01); F23G 5/30 (2006.01); F23G 5/46 (2006.01); F23J 15/02 (2006.01); F23J 15/04 (2006.01)**

CPC (source: EP KR)

**F23G 5/027 (2013.01 - EP KR); F23G 5/16 (2013.01 - EP); F23G 5/30 (2013.01 - EP); F23G 5/46 (2013.01 - EP); F23J 15/022 (2013.01 - EP); F23J 15/025 (2013.01 - EP); F23J 15/04 (2013.01 - EP); F23G 2207/30 (2013.01 - EP); F23L 2900/07002 (2013.01 - EP); F23L 2900/07009 (2013.01 - EP)**

Citation (search report)

- [XA] US 4848249 A 19890718 - LEPORI WAYNE A [US], et al
- [XA] WO 9012248 A1 19901018 - ALBERTSON ORRIS E [US], et al
- [XA] US 4676177 A 19870630 - ENGSTROM FOLKE [FI]
- [XA] EP 0999412 A1 20000510 - HITACHI SHIPBUILDING ENG CO [JP]
- See references of WO 0190645A1

Cited by

CN102200284A; EP1816396A4; CN103104922A; US7947095B2; WO2006123018A1

Designated contracting state (EPC)

DE FR GB

DOCDB simple family (publication)

**EP 1284389 A1 20030219; EP 1284389 A4 20050316; KR 100447009 B1 20040904; KR 20020025900 A 20020404; WO 0190645 A1 20011129**

DOCDB simple family (application)

**EP 00929845 A 20000524; JP 0003306 W 20000524; KR 20017016391 A 20011221**